Docket No.: 8733.857.00

Declaration, Power of Attorney and Petition

WE (I) the undersigned inventor(s), hereby declare(s) that:

My residence, post office address and citizenship are as stated below next to my name,

We (I) believe that we are (I am) the original, first, and joint (sole) inventor(s) of the subject matter which is claimed and for which a patent is sought on the invention entitled

ALIGNING METHOD UNDER ELECTRIC FIELD FOR FERROELECTRIC LIQUID CRYSTAL AND LCD USING THE SAME

the specification of which

X	is attached here	ed hereto.				
	Was filed on					
-	1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	as Application No.				
	and Arthur	and amended on				
	Was filed as PCT international application					
	Number					
	On .					
	and was amende	ed under PCT Article 19				
On			(if applicable).			

We (I) hereby state that we (I) have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

We (I) acknowledge the duty to disclose information known to be material to the patentability of this application as defined in Section 1.56 of Title 37 Code of Federal Regulations.

We (I) hereby claim foreign priority benefits under 35 U.S.C. §119(a)-(d) or §365(b) of any foreign application(s) for patent or inventor's certificate, or §365(a) of any PCT International application which designated at least one country other than the United States, listed below and have also identified below, by checking the box, any foreign application for patent or inventor's certificate, or PCT International application having a filing date before that of the application on which priority is claimed. Prior Foreign Application(s)

Application No.	Country	Day/Month/Year	Priority Claimed			
P2002-79345	Korea	12 December 2002	×	Yes		No
				Yes		No
				Yes		No
		E		Yes		No

We (I) hereby claim to provisional application(s) listed		35, United	States Code,	§119(e) of any United State	
(Applicati	on Number)		Filing Date)		
We (I) hereby claim the any PCT International application each of the claims of this application in the manner provided by the fi- which is material to patentabilit the prior application and the nat	on designating the United attion is not disclosed in irst paragraph of 35 U.S. y as defined in 37 CFR {	States, list the prior C. §112, I	sted below and, United States of acknowledge to the became avail	r PCT International application he duty to disclose information able between the filing date o	
Application Serial No.	Filing Date		Status (pendi	ng, patented, abandoned)	
regarding this application be set K Street, N.W., Washington, D. We (I) declare that all statements made on information with the knowledge that willful both, under Section 1001 of T jeopardize the validity of the appropriate the statements.	C. 20006. I statements made here I and belief are believed false statements and the itle 18 of the United St	in of our to be true like so ma tates Code	(my) own kno; ; and further th de are punishal e and that such	owledge are true and that all at these statements were made ole by fine or imprisonment, or	
Hong Chul Kim		Resid	ence: #204,	#204, 1112-37, Bono-dong	
NAME OF FIRST INVENTOR	₹ :	Ahnsan-shi, Kyounggi-do, Korea			
	1	Citize	n of Repub	lic of Korea	
Signature of Inventor			Office Address:	Same as above	
Date					
2023.6.23		Resid	ence:		
NAME OF SECOND INVENTOR					
		*			
		Citize	n of:		
Signature of Inventor		Post C	Office Address:	· · · · · · · · · · · · · · · · · · ·	

Date

Docket No. 87	33.857.00						
	IN THE U	NITED STATES PATI	ENT AND TRADE	MARK O	FFICE		
IN RE APPLIC	CATION OF:	Hong Chul KIM	GAU:		ТВА		
SERIAL NO:	Not Yet Assig	ned	EXAMI	NER:	ТВА		
FILED:	FILED: June 30, 2003						
FOR: ALIGNING METHOD UNDER ELECTRIC FIELD FOR FERROELECTRIC LIQ CRYSTAL AND LCD USING THE SAME					ROELECTRIC LIQUID		
COMMISSION P.O. Box 1450 Alexandria, VA	ER FOR PATEN	-	OR PRIORITY				
SIR:							
pursuant to	the provisions o	f 35 U.S.C. §120.			ed [US App Dt], is claimed		
the provision	ons of 35 U.S.C.	§119(e).			l, is claimed pursuant to		
1 1 1		o priority from any earl f 35 U.S.C. §119, as no		to which t	they may be entitled		
In the matter of priority:	f the above-ident	ified application for pate	ent, notice is hereby	given that	the applicants claim as		
COUNTRY		APPLICATION NU	MBER	MONTH/DAY/YEAR			
KOREA		P-2002-0079345		12 December 2002			
			• ;				
		nding Convention Appl	ication(s)				
	bmitted herewith						
will be s	submitted prior to	payment of the Final F	l'ee				
□ were file	ed in prior applic	ation Serial No. filed			v		
Receipt	vere submitted to the International Bureau in PCT Application Number. Leceipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has een acknowledged as evidenced by the attached PCT/IB/304.						
□ (A) App	oplication Serial No.(s) were filed in prior application Serial No. filed ; and						
(B) App	3) Application Serial No.(s)						
□ ar	re submitted herewith						
□ wi	□ will be submitted prior to payment of the Final Fee						
, 			Respectfully Su	ibmitted,			
Date:June 30, 2003			McKENNA LC	McKENNA LONG & ALDRIDGE LLP			
1000 K Street N W	,		Cana II I				
1900 K Street, N.W. Washington, D.C. 20006 Tel. (202) 496-7500 Fax. (202) 496-7756			Song K. Jung	Song K. Jung			
			Registration	1 No. 35.	,210		

